

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenneth C. Johnson et al.

Application No.: 10/777,353

Filed: February 12, 2004

For: DATABASE INTERPOLATION

METHOD FOR OPTICAL

MEASUREMENT OF DIFFRACTIVE

MICROSTRUCTURES

Confirmation No.: 5063

Group Art Unit: 2857

Examiner: Carol S.W. Tsai

LOSS OF ENTITLEMENT TO SMALL ENTITY STATUS 37 C.F.R. §1.28(b)

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on Aug. 1, 2005

STALLMAN & POLLOCK LLP

M/S ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The status of the owner of this patent has changed from that of a small entity to other than that of a small entity.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: 8)1(or

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Atty Docket No.: TEL-0000 [TWI-30510]